30. (New) The method of claim 26, wherein each of the cartridges include a pair of wings extending from an outer surface thereof, wherein the receptacle includes a pair of slots formed therein that are adapted to receive the pair of wings, and wherein the cartridge is attached to the receptacle by extending the pair of wings through the pair of slots and rotating the cartridge with respect to the receptacle.

REMARKS

Claims 1-17 are pending and disclosed as part of U.S. Patent No. 6,319,297. By this Preliminary Amendment, claims 18-30 have been added.

Pursuant to the requirements of 37 C.F.R. 1.173(c), support for each added claim is found in the specification as follows:

No.	Claim Text	Corresponding Specification Disclosure
18.	(New) A system comprising: a wafer enclosure for receiving a plurality of wafers, the wafer enclosure comprising an enclosure portion with an opening and a door to sealingly close the opening, wherein the enclosure has a receptacle; a set of cartridges configured to sealingly engage the wafer enclosure through the receptacle, wherein the set of cartridges comprise at least two different cartridges selected from the group consisting of a valve, a filter, a conditioning agent and a blank.	Column 5, lines 13-16 Column 5, lines 39-42; lines 50-54; figure 3. Column 6, lines 16-17; column 7, lines 10-14; figures 6A-6F.
19.	(New) The system of claim 18, wherein each of the cartridges have an annular shape.	Column 5, lines 33-35; figures 1-2.

No.	Claim Text	Corresponding Specification Disclosure
20.	(New) The system of claim 19, wherein each of the cartridges has a pair of wings extending from an outer surface thereof.	Column 5, lines 25-30; figures 1-2.
21.	(New) The system of claim 19, wherein each of the cartridges has at least one slot formed in an inner surface thereof.	Column 5, lines 25-30; figures 1-2.
22.	(New) The system of claim 18, and further comprising an interface seal that provides a substantially gas-tight seal between the receptacle and one of the cartridges that is attached to the wafer enclosure.	Column 5, lines 50-54; figure 3.
23.	(New) The system of claim 18, wherein each of the cartridges may be removably attached to the receptacle without removing wafers from the wafer enclosure.	Column 7, lines 51-55
24.	(New) The system of claim 18, wherein the receptacle is positioned on a bottom portion of the wafer enclosure.	Column 5, lines 31-33; figure 3.
25.	(New) The system of claim 24, wherein the receptacle is at least partially recessed in the bottom portion.	Column 5, lines 31-33; figure 3.
26.	(New) The system of claim 18, wherein the wafer enclosure is a SMIF pod.	Column 5, lines 6-11.
27.	(New) A method of selectively adapting a wafer enclosure to a desired purging capability, the wafer enclosure having an enclosure portion with an opening and a door to sealingly close the opening, wherein the enclosure has a receptacle, the method comprising:	Column 5, lines 13-16
	providing a workstation having a work space and a set of cartridges that includes at least two different cartridges selected from the group consisting of a valve, a filter, a conditioning agent and a blank selecting one of the cartridges from the set of cartridges that correlates to the desired purging capability;	Column 7, lines 56-63; figure 7 Column 6, lines 16-17; column 7, lines 10- 14; figures 6A-6F.
	positioning the cartridge in the work space; moving the cartridge into the receptacle; and attaching the cartridge to the wafer enclosure through the	Column 8, lines 8-12. Column 8, lines 15-17

No.	Claim Text	Corresponding Specification Disclosure
	receptacle.	
28.	(New) The method of claim 26, wherein one of the cartridges is moved into the receptacle with an elevator.	Column 7, lines 63-67; column 8, lines 15-17.
29.	(New) The method of claim 27, and further comprising engaging the cartridge with a pair of keys that extend from the elevator.	Column 8, lines 5-19.
30.	(New) The method of claim 26, wherein each of the cartridges include a pair of wings extending from an outer surface thereof, wherein the receptacle includes a pair of slots formed therein that are adapted to receive the pair of wings, and wherein the cartridge is attached to the receptacle by extending the pair of wings through the pair of slots and rotating the cartridge with respect to the receptacle.	Column 5, lines 25-30; figures 1-2. Column 5, lines 64-67 to column 6, lines 1-5; figures 4-5.

In view of the foregoing, it is submitted that this application is in condition for allowance. Favorable consideration and prompt allowance of the application are respectfully requested.

The Examiner is invited to telephone the undersigned if the Examiner believes it would be useful to advance prosecution.

Respectfully submitted,

Michael A. Bondi

Registration No. 39,616

Customer No. 24113

Patterson, Thuente, Skaar & Christensen, P.A. 4800 IDS Center 80 South 8th Street Minneapolis, Minnesota 55402-2100

Telephone: (612) 349-5771

Reissue Application for U.S. Patent No. 6,319,297

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"Express Mail" mailing label number EV320340474US. Date of Deposit: November 20, 2003. I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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Name of Person Making Deposit	Signature